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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/743,985

Confirmation No.: 9060

In re application of: Shui-Ming Cheng et al.

Filed: December 22, 2003

Technology Center/Art Unit: 2813

Examiner: Laura M. Schillinger

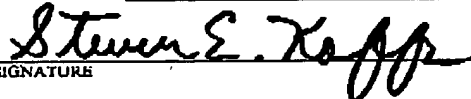
Docket No.: N1085-00168 (2003-0219)

Customer No.: 08933

Title: BODY CONTACT FORMATION IN
PARTIALLY DEPLETED SILICON ON
INSULATOR DEVICEI CERTIFY THAT THIS CORRESPONDENCE COMPRISED OF EIGHT
(8) PAGES IS BEING TRANSMITTED BY FACSIMILE TO THE PATENT
AND TRADEMARK OFFICE ON THE DATE AND TO THE FACSIMILE
NUMBER SHOWN BELOW

ON: August 24, 2005

FACSIMILE NO. 571.273.8300


SIGNATUREMail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450AMENDMENT

Sir:

Responsive to the Office Action dated March 1, 2005, please amend the above-identified application as follows:**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.**Remarks/Arguments** begin on page 8 of this paper.